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DOCKET: BUR920010052US1

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

INVENTOR:	Christopher K. Magg	)	EXAMINER:	Kripa Sagar
		)		
SERIAL NO.:	09/683,929	)	ART UNIT:	1756
		)		
FILING DATE:	March 4, 2002	)	DATE:	May 25, 2004

FOR: HARDMASK/BARRIER LAYER  
FOR DRY ETCHING CHROME  
FILMS AND IMPROVING  
POST DEVELOP RESIST  
PROFILES ON PHOTOMASKS

**AMENDMENT UNDER RULE 312**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Notice of Allowance mailed May 18, 2004, please amend the  
application as described below.